

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1577		SERIAL NO. 09/730,335	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Charles H. Dennison			
				FILING DATE December 4, 2000		GROUP 2811	

U.S. PATENT DOCUMENTS							
Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
ON	AA	5,923,999	07/13/99	Balasubramanyam et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS							
Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
ON	AJ	JP63012132	01/19/88	Japan (Sumi et al.)			Abstract
	AK	JP63012152	01/19/88	Japan (Tsukamoto et al.)			Abstract
	AL	JP8017758	01/19/96	Japan (Tawara)			Abstract & machine

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AM			
AN			
AO			

EXAMINER <span style="font-size: 1.5em;">ON</span>	DATE CONSIDERED <span style="font-size: 1.5em;">2/9/04</span>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. MI22-1577		SERIAL NO. 09/730,335	
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Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
ON	AJ	JP8279553	10/22/96	Japan (Fujiwara)			Abstract & machine
ON	AK	JP10093077	04/10/98	Japan (Tsukamoto)			Abstract & machine
	AL						

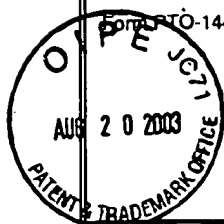
  

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
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Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate		
ON	AA	5,696,017	12/9/97	Ueno				
ON	AB	6,357,909 B1	3/25/03	Lin, et al.				
	AC							
	AD							
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	AL							
<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>								
ON	AM	J. Nulman, B. Cohen, and K. Ngan, "Titanium Silicide and Titanium Nitride Layers Formed in an integrated Multichamber System", Proc. VMIC Conference (1991), pp. 312-315.						
ON	AN	William C. O'Mara, Robert B. Herring, and Lee p. Hunt, "Handbook of Semiconductor Silicon Technology", Noyes Publ., Norwich, New York (1990), p. 684.						
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